INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 30, 2026

IGI Report Number	LG839675703
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MODIFIED MARQUISE STEP CUT
Measurements	9.66 X 4.91 X 3.02 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	G
Clarity Grade	VVS 2

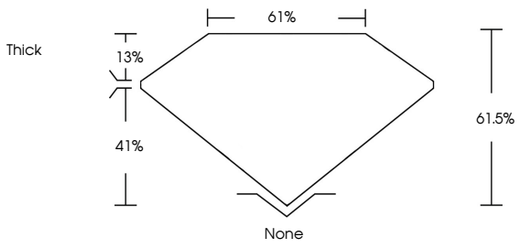
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG839675703

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG839675703
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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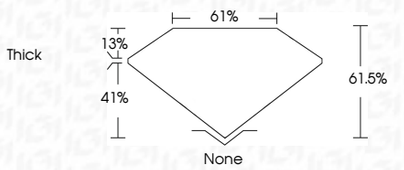
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IGI

September 30, 2026
IGI Report No:LG839675703
MODIFIED MARQUISE STEP CUT
9.66 X 4.91 X 3.02 MM
Carat Weight 1.01 CARAT
Color Grade G
Clarity Grade VVS 2
Depth 61.5%
Table 61%
Girdle Thick
Culet None
Polish EXCELLENT
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG839675703
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa